

United States Patent and Trademark Office



CONFIRMATION NO. 3979

Bib Data Sheet	•							- " • • • • • • • • • • • • • • • • • • •		
SERIAL NUMB 10/709,980	ER	FILING DATE 06/10/2004 RULE	CLASS 117		GROUP ART UNIT 1722			ATTORNEY DOCKET NO. TOPP0016USA		
APPLICANTS							•			
Ching-Wei					•					
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** FOREIGN APPLICATIONS ************************************										
IF REQUIRED, F ** 07/15/2004	OREI	GN FILING LICENSE	GRANTE	ED .						
Foreign Priority claimed				STATE OR	SHE	EETS TOTA		AL	INDEPENDENT	
Verified and Acknowledged Examiner's Signature Acknowledged Acknowledged				COUNTRY TAIWAN		DRAWING CLAI			CLAIMS 1	
ADDRESS 027765 NORTH AMERIC P.O. BOX 506 MERRIFIELD, V 22116		ERNATIONAL PATEN	IT OFFIC	CE (NAIPC)					•	
TITLE METHOD OF FO	RMIN	G A THIN FILM TRAN	SISTOR	BY UTILIZING	G A LA	SER CF	RYSTALI	_IZAT	ION PROCESS	
							All Fees			
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RECEIVED 770	No for following:				time) 1.18 Fees (Issue)					
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